

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/646,044	CHEMELWSKI, DAVID
	Examiner	Art Unit
	Benjamin C. Lee	2632

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
340	932.2	12/26/05	mg
	942	↓	↓
	556	↓	↓